

Evaluation of post-irradiation performance of ATLAS18 strip sensors affected by low p-stop issue

J. Fernández-Tejero, E. Bach, V. Cindro, V. Fadeyev, P. Federicova, C. Fleta, J. Kozakova,
J. Kroll, J. Kvasnicka, I. Mandic, M. Mikestikova, **M. Ullán***, Y. Unno, D. Valero

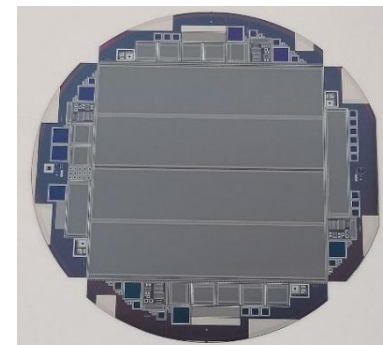
***miguel.ullan@imb-cnm.csic.es**

- Introduction and Framework
 - ATLAS-ITk strip sensors production
 - P-stop element
 - Low P-stop issue
- Experiment
 - Proposal
 - Samples and tests
 - Irradiations
- Results
 - Main sensors
 - CCE (minis)
 - Rint (minis)
- Conclusion and Future Work

- Production of ATLAS-ITk ATLAS18 strip sensors

See Thomas Koffas' "Phase-2 Upgrade of the ATLAS Inner Tracker" Oral #19 in this conference

- Need to produce ~24000 sensors (Hamamatsu HPK - Japan)
- The ITk collaboration does the testing
 - QC: To test the actual sensors to be installed in the experiment
See: Pavla Federicova's "Evaluation of quality control (QC) of ATLAS18 production ITk strip sensors", Oral #39 in this conference
 - QA: to monitor the technology parameters and post-irrad performance throughout prod.
See: Robert Orr's "Quality Assurance during production of the ATLAS18 Itk strip sensors", Oral #49 in this conference

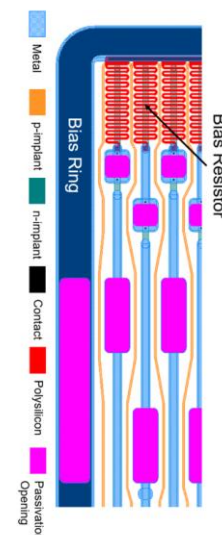
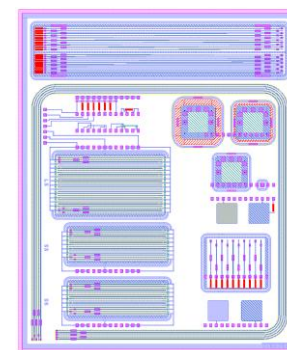
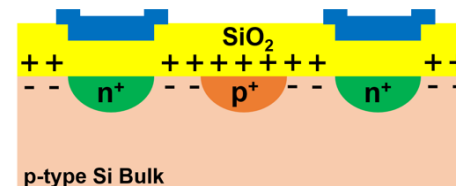


- P-stop component

- P-stop is a p-doped layer in between the n+ strips to provide interstrip isolation pre- and post-irrad due to interface and oxide charge

- P-stop monitoring with test structures

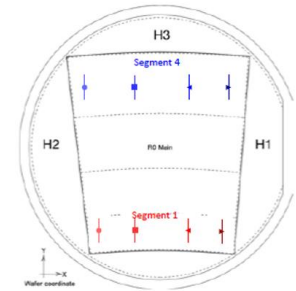
- MOS with P-stop
 - An MOS capacitor between the P-doped substrate and metal, with field-oxide in between
- PTP
 - A special structure for sensor protection with important role, and effect, of the p-stop layer



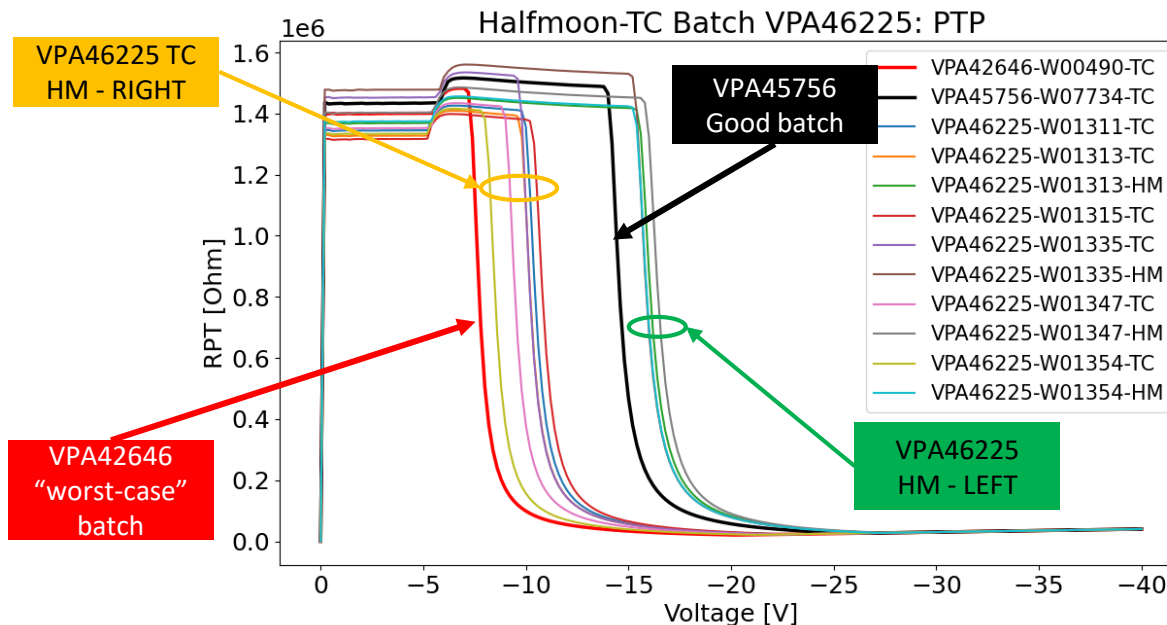
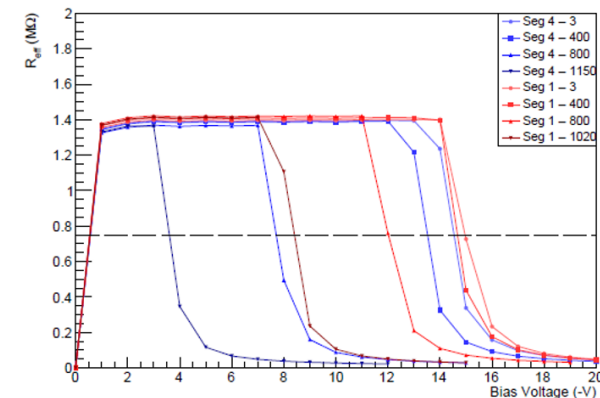
M. Ullán, et al. "Quality Assurance Methodology for the ATLAS Inner Tracker Strip Sensor Production", NIMA, vol. 981, 164521, 2020

Low P-stop Issue I

- In some batches we have seen indications of low P-stop doping
 - Seen in the MOS capacitor with P-stop as a fast depletion rate (next slide)
 - Also confirmed with PTP measurements (see below)
 - Confirmed by simulations (See: [Yoshinobu Unno's poster #63 in this conference](#))
 - There is a clear inhomogeneity in the doping concentration within the batch and within the wafer
 - Only a small number of wafers of the batch are affected
 - **In most cases, the left side of the wafer is not affected**
 - 4 full production batches rejected for this reason
- Effect clearly seen in Punch Through Voltage:



PTP -- VPA42646 W531

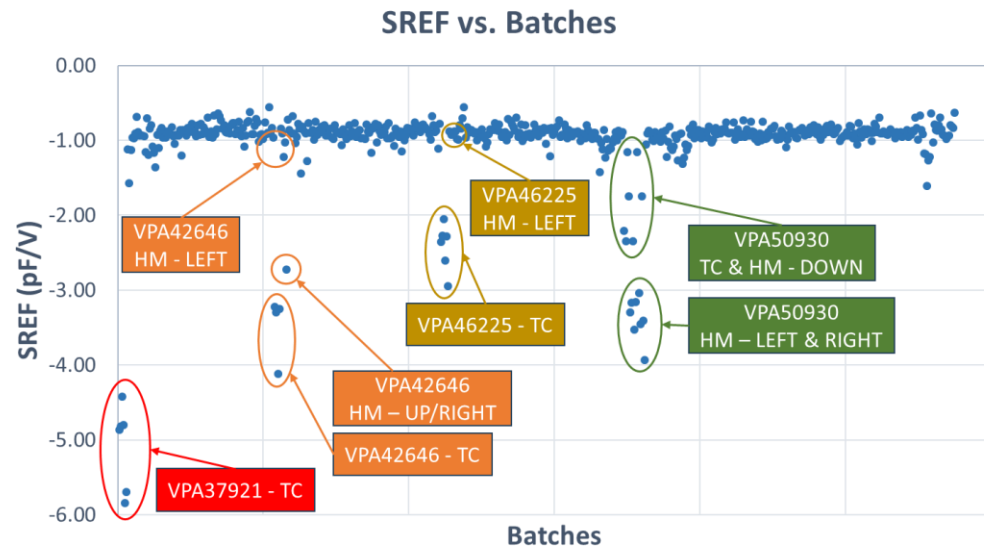
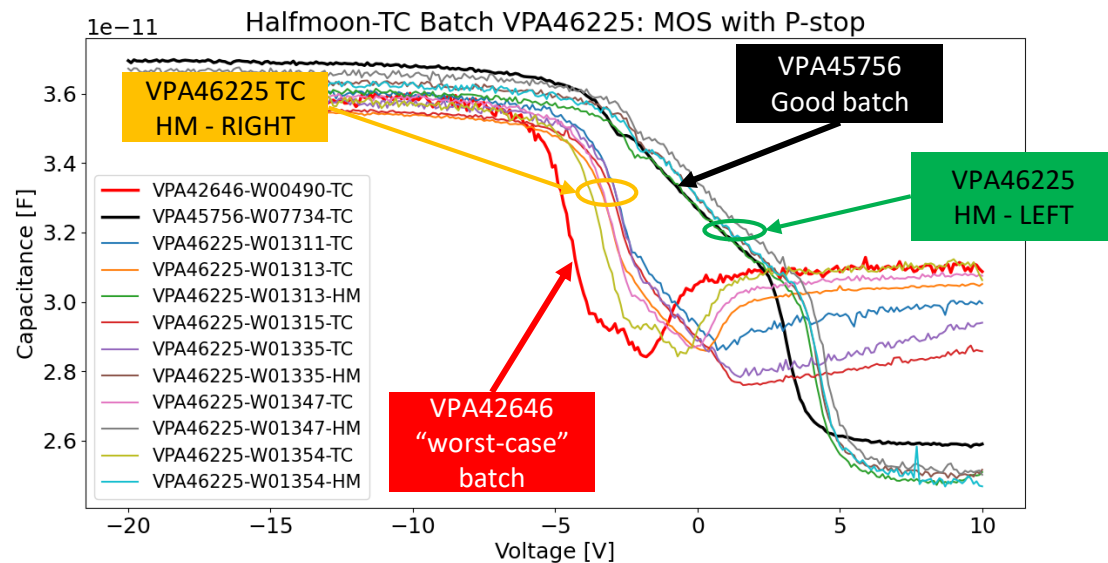
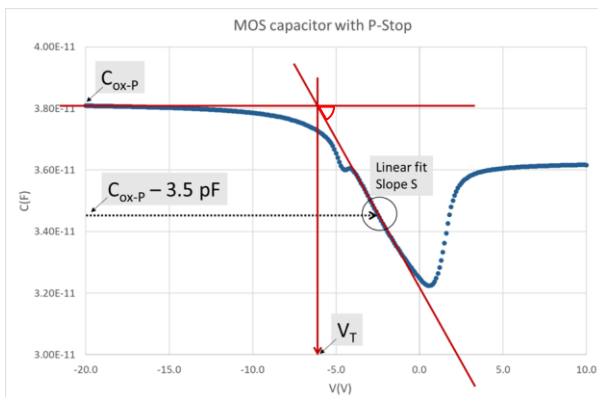


Estimated p-stop density:

- 16 V: $\sim 4 \times 10^{12} \text{ cm}^{-2}$ (1)
- 12 V: $\sim 2 \times 10^{12} \text{ cm}^{-2}$ (1/2)
- 7.5 V: $\sim 1 \times 10^{12} \text{ cm}^{-2}$ (1/4)
- 4 V: $\sim 5 \times 10^{11} \text{ cm}^{-2}$ (1/8)

MOS with P-stop

- Sref
 - Slope of the curve from accumulation to depletion
 - Clear indicator of the issue
 - Used as figure-of-merit in QA tests



- The simulations indicate that the results are compatible with an order of magnitude reduction, in the worst case, in the P-stop doping concentration
 - See:
 - [Yoshinobu Unno, et al, "Analysis of MOS capacitor with p-layer with TCAD simulation" NIMA 1064, 170045 \(2024\)](#)
 - [Yoshinobu Unno, et al., "Measurement of Threshold Voltage in PTP Structures and Estimation of P-stop Density Variation Within an ATLAS18 Silicon Strip Sensor Wafer Using TCAD Simulations", poster #63, this conference.](#)
- We have not seen clear effects in other QA/QC tests pre-irrad apart from PT voltage reduction
 - Some cases of areas of low pre-irrad interstrip isolation in main sensors (not necessarily related to low P-stop doping reduction, e.g., static charge build-up)
- We do not know if this can have direct consequences post-irrad
 - Some sensors with slightly lower P-stop doping might have passed undetected due to QA batch sampling
- This work tries to find out the consequences of the low P-stop doping on the sensors performance in the real experiment (post-irrad)
- ☞ The foundry has identified the origin of the problem and mitigated it
- ☞ Also HPK has proposed process variations to make a more robust fabrication
 - See: [Jana Kozakova's "Evaluation of Performance of the p-stop Process Splits in ATLAS18 strip sensors, Pre- and Post-Irradiation", poster #68, this conference](#)

Three experiments:

1. Take one MAIN sensor and irradiate it with $\gamma+n$ up to target fluences

- Fast “final” result of the full degradation
- Use the sensor with the worst (lowest) p-stop doping (W514)

2. Try some intermediate fluences with MAIN sensors

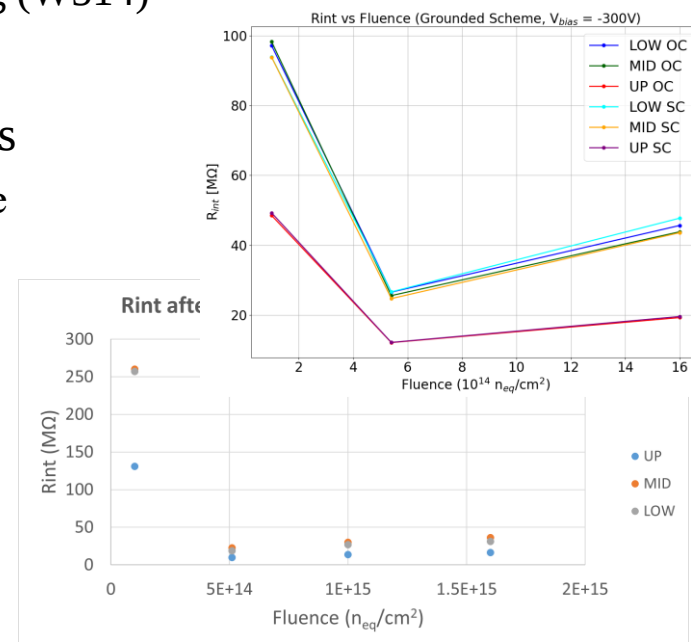
- We have seen a “minimum” in R_{int} at “mid” fluence
 - ❑ $5.1 \times 10^{14} \text{ neq/cm}^2 \parallel 21 \text{ Mrad}$

[J. Fernandez-Tejero, et al. “Evolution of the electrical characteristics of the ATLAS18 ITk strip sensors with HL-LHC radiation exposure range,” 2025 JINST 20 C01010](#)

- This would be a “worst-case” scenario
- We could also try other fluences close to that in order to approximate to the “minimum”

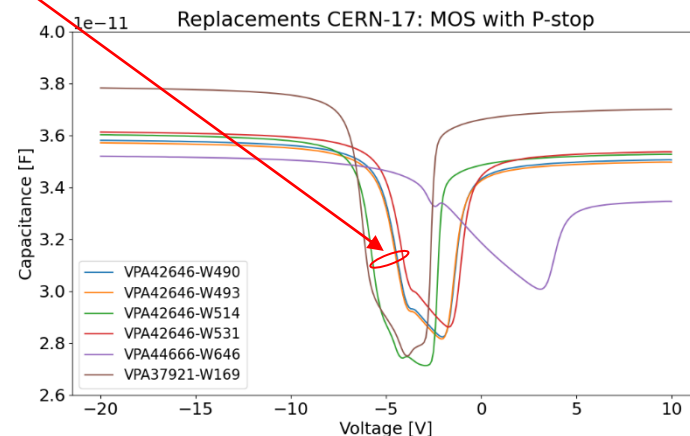
3. Irradiate several mini sensors only with gammas to see the degradation of R_{int}

- Identify the TID of “fail” ($R_{int} < 15 \text{ MOhm}$) for “good” and “bad” P-stop cases
- Find the “saturation of degradation” (if any)
- Later add neutron fluence to learn when and how the R_{int} “recovers” to acceptable values



Experiment 1 and 2 (MAIN sensors)

- Use main sensors from rejected batch **VPA42646** (R0, CERN-17)
 - This is a rejected batch with quite bad P-stop results
- Irradiate with gammas + neutrons
- **MAIN sensors** doses and fluences:
 - W531: 2.0 Mrad, $5e13$ neq/cm²
 - W532: 4.1 Mrad, $1e14$ neq/cm²
 - W493: 16.5 Mrad, $4.0e14$ neq/cm²
 - W490: 21 Mrad, $5.1e14$ neq/cm²
 - W514: 66 Mrad, $1.6e15$ neq/cm²
- Additionally, **mini sensors** affected by low P-stop (TC tests) have been irradiated together with the MAIN sensors for CCE tests
 - 1) W492: 66 Mrad, $1.6e15$ neq/cm²
 - ➔ This case is obtained from proton (MC40) irradiations with good CCE
 - 2) W531: 21 Mrad, $5.1e14$ neq/cm²
 - 3) W493: 16.5 Mrad, $4e15$ neq/cm²

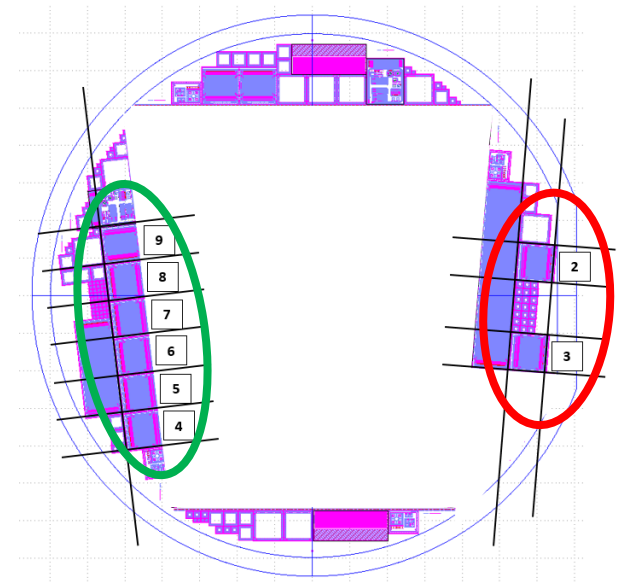


Measurements:

- Rint, CCE of minis

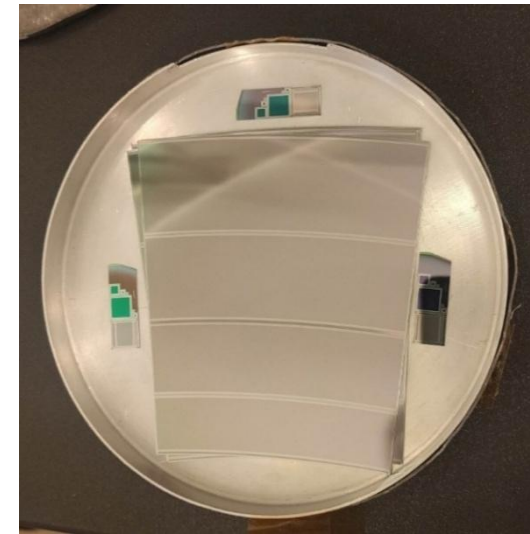
Experiment 3 (mini sensors)

- Dice minis from the Halfmoons (HM) of affected wafers
 - W490, W493, W514 and W531
 - We know that the low P-stop effect is affecting the right side of the wafers → dice minis from the left and the right HM of those wafers, we can have minis with proper P-stop and with low P-stop, in order to do the whole experiment with good sensors and "bad" sensors
- Batch **VPA42646 (R0)**
 - Wafers: **W490, W493, W514**
- Dice 6 minis of each type (**good/left**, **bad/right**),
 - Dicing scheme
- Irradiate up to 6 doses:
1, 3, 5, 10, 21, 66 Mrad
- Later, also complete with neutron irradiations



- MAIN sensors
 - 5 cases
- Mini sensors for CCE tests
 - 3 cases
- Mini sensors for damage study (TID)

Wafer	type	Position on the wafer	Gamma irradiation
W490	MINI 4	left	1 Mrad
W490	MINI 5	left	3 Mrad
W490	MINI 6	left	5 Mrad
W490	MINI 7	left	10 Mrad
W490	MINI 8	left	21 Mrad
W490	MINI 9	left	66 Mrad
W490	MINI 3	right	1 Mrad
W490	MINI 2	right	3 Mrad
W493	MINI 3	right	5 Mrad
W493	MINI 2	right	10 Mrad
W514	MINI 3	right	21 Mrad
W514	MINI 2	right	66 Mrad

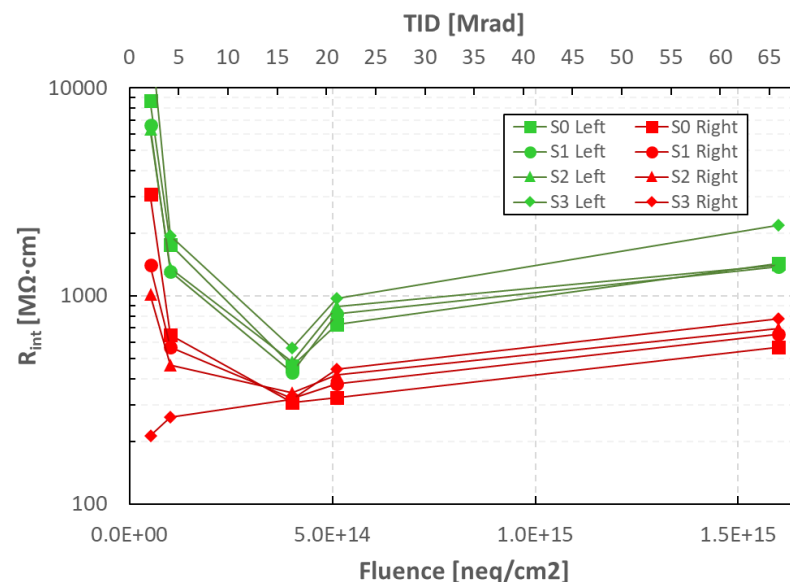
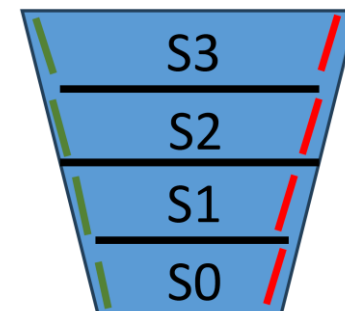


Setup for gamma irradiations of MAIN sensors and minis



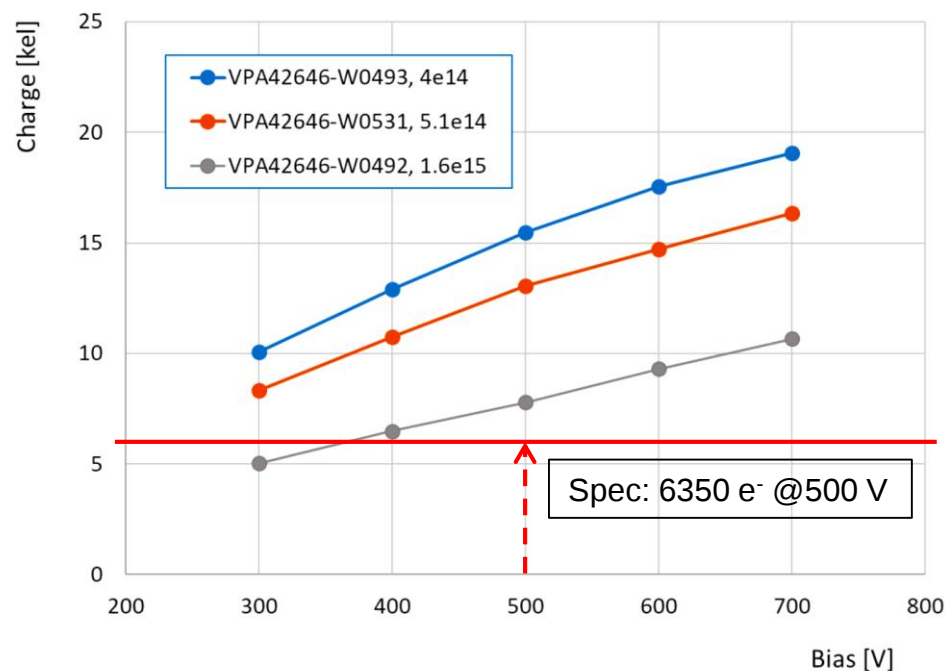
MAIN sensors ($\gamma + n$)

- Experiment 1 (target $\gamma+n$) and 2 (intermediate $\gamma+n$)
- Interstrip resistance (Rint) measurements at **left/good** and **right/bad** strips of the sensor
- Decrease of Rint up to $4e14$ neq/cm² and then increase for higher fluences
 - Initial influence of TID effects (Rint ↓)
 - Later, displacement damage dominates (Rint ↑)
- **Significantly lower Rint values at right side of the sensor for all cases → low P-stop**
 - Density estimated to be ~ 0.5 to 1×10^{12} cm⁻² ($\sim 1/8$ to $1/4$) using TCAD simulations
- **Still well within specifications**
- One “special case” we will discuss later

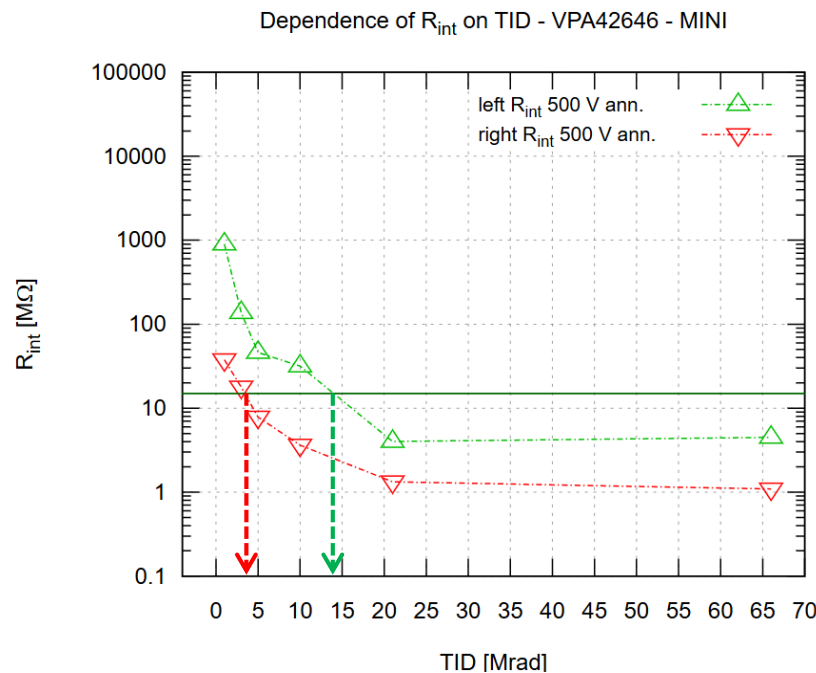


CCE results

- Mini sensors from VPA42646 irradiated together with full size sensors ($\gamma + n$)
- **All samples passed threshold of specifications (6350 e⁻ @500V)**



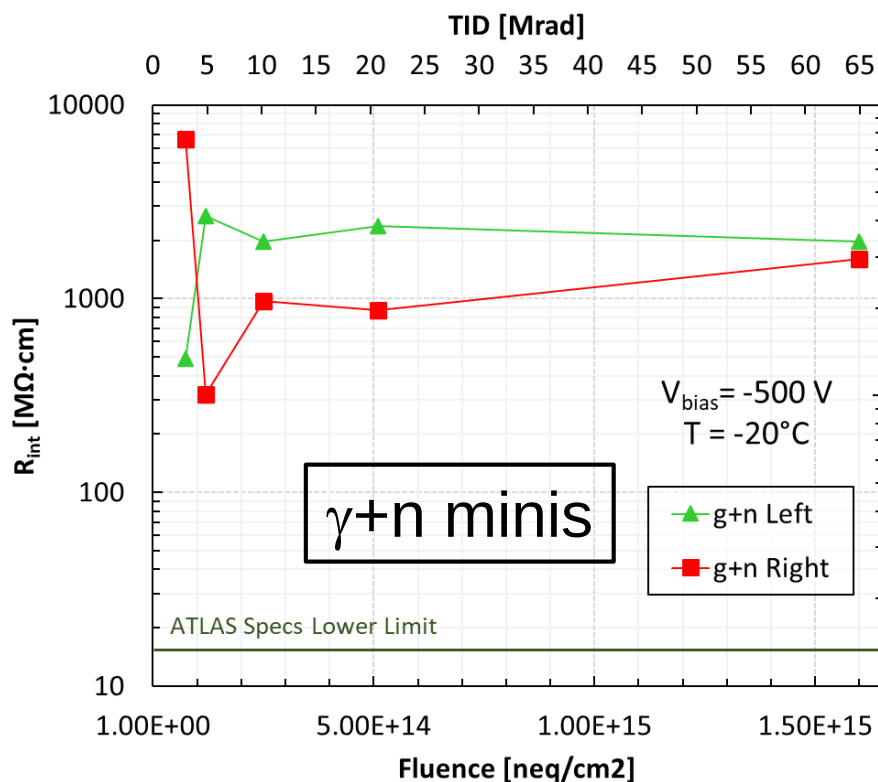
- Experiment 3: R_{int} of minis from **affected**/**not affected** by low P-stop



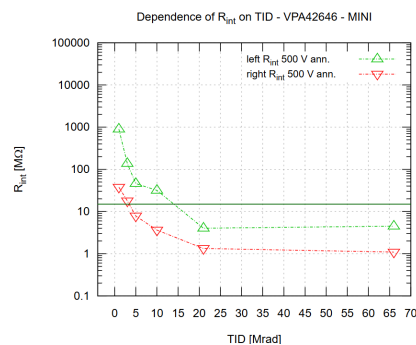
- **Dose at which $R_{int} < \text{specs}$ is significantly lower for low P-stop cases**
 - ~14 Mrad for “good” minis // ~4 Mrad for low P-stop minis
 - ☞ Only gammas !! → therefore worse than expected in the real experiment
- Saturation of TID damage
- Next: complete with neutron irradiations to see the R_{int} evolution in the real scenario

Results: minis ($R_{int} \leftarrow \gamma+n$)

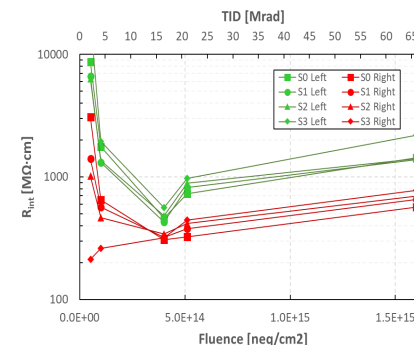
- R_{int} @500 V for $\gamma+n$ irradiated minis
- **R_{int} significantly lower for low P-stop minis**
 - Still well above specifications
- **Minimum of R_{int} possibly influenced by P-stop doping level**
 - Will investigate the position (and value) of the minimum



γ minis



$\gamma+n$ MAIN



- During the ~4.5 years production of the ATLAS-ITk strip sensors, we have found some cases (batches) in which the doping of the P-stop layer was significantly lower than expected
 - We have identified this through specific test structures, during Quality Assurance (QA) tests, and also with tests in the actual sensors (QC)
 - Nevertheless, the sensors remain within specifications pre-irrad
 - In this work we try to identify the effect of this low P-stop doping in the real experiment (post-irradiation)
- **MAIN sensors: Significantly lower interstrip resistance (R_{int}) values for low P-stop strips → Still well within specifications**
- **CCE results (mini sensors): All samples well above specifications**
- **Gamma irradiations (minis): Dose at which $R_{int} < \text{specs}$ is significantly lower for low P-stop cases**
- **Minis ($\gamma+n$): R_{int} significantly lower for low P-stop minis**
 - Still well above specifications

👉 Next: Detailed quantitative search of minimum of R_{int} vs. TID+NIEL

Thank you

Backup

MAIN sensors ($\gamma + n$)

